

35.C14241

PATENT APPLICATION

4 / Letter
Lewis
10/5/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
NOBUHIRO ITO) : Examiner: Unassigned
Application No.: Unassigned) : Group Art Unit: Unassigned
Filed: February 16, 2000)
(Concurrently Herewith) :
For: MANUFACTURING METHOD :
OF ELECTRON BEAM)
APPARATUS AND SPACER, : February 16, 2000
AND ELECTRON BEAM)
APPARATUS :

Assistant Commissioner for Patents
Washington, D.C. 20231

COMMUNICATION

Sir:

This application is being filed in the Japanese language pursuant to MPEP 608.01 and 37 CFR 1.52(d). Applicant will file an English translation of the specification and claims, along with a statement that the translation is accurate, an executed declaration, and any additional fees, at the time to be set forth by the Patent Office.

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Applicant's undersigned attorney may be reached in
our Washington, D.C. office by telephone at (202) 530-1010.
All correspondence should continue to be directed to our
below listed address.

Respectfully submitted,



Attorney for Applicant

Registration No. 45,133

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

MAW\SWS

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